



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of: Wu et al.

Attorney Docket No.:
NOVLP094/NVLS-2919

Application No.: 10/789,103

Examiner: Bret Chen

Filed: February 27, 2004

Group: 1762

Title: METHODS FOR PRODUCING LOW-K CDO FILMS WITH LOW RESIDUAL STRESS

CERTIFICATE OF MAILING

I hereby certify that this correspondence is being deposited with the U.S. Postal Service with sufficient postage as first-class mail on March 27, 2006 in an envelope addressed to the Commissioner for Patents, P.O. Box 1450 Alexandria, VA 22313-1450.

Signed:

Tara Hayden

AMENDMENT TRANSMITTAL

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

Transmitted herewith is an Amendment in the above-identified application.

The fee has been calculated as shown below.

	Claims After Amendment		Highest Previously Paid For	Present Extra	Small Entity Rate Fee	Large Entity Rate Fee
Total Claims	39	MINUS	51	00	x 25 =	x 50 =
Independent Claims	03	MINUS	04	00	x 100 =	x 200 =
Multiple Dependent Claim Present and Fee Not Previously Paid						
				Total	\$	\$

Applicant(s) hereby petition for a month extension(s) of time to respond to the aforementioned Office Action.

Applicant(s) believe that no (additional) Extension of Time is required; however, if it is determined that such an extension is required, Applicant(s) hereby petition that such an extension be granted and authorize the Commissioner to charge the required fees for an Extension of Time under 37 CFR 1.136 to Deposit Account No. 500388.

Enclosed is our Check No. in the amount of \$ to cover the additional claim fee and/or extension of time fees.

Please charge the required fees, or any additional fees required to facilitate filing the enclosed response, to Deposit Account No. 500388 (Order No. NOVLP094).

Respectfully submitted,
BEYER WEAVER & THOMAS, LLP

Denise Bergin
Denise S. Bergin
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RESPONSE TO OFFICE ACTION

Mail Stop Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Dear Sir:

In response to the Office Action dated December 27, 2005 in the above-identified application, please amend the application as follows:

Amendments to the Specification appear on page 2 of this paper

Amendments to the claims are reflected in the **Listing of Claims** that begins on page 3 of this paper.

Remarks/Arguments begin on page 8 of this paper.